

MAY-01-2002 16:39 FROM

TO 76#1309022\*1725#1703 P.04/05


Appl. N . 09/932,236

**REMARKS**

Claims 24-41 are cancelled, leaving claims 1-23 pending in the application. In response to the Examiner's request for restriction of the claims in the application, applicant elects to prosecute the claims of group I (claims 1-23). Applicant requests substantive examination of pending claims 1-23 in the Examiner's next action.

Dated: 5/1/02

Respectfully submitted,

By:   
David G. Latwesen, Ph.D.  
Reg. No. 38,533

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Appl. No. 09/932,236

Application Serial No. ....09/932,236  
Filing Date .....August 16, 2001  
Inventor..... Hianing Yang  
Assignee..... Micron Technology, Inc.  
Group Art Unit.....2813  
Examiner ..... Hogans, David L.  
Attorney's Docket No. ....MI22-1725  
Title: Methods of Forming Metal-Comprising Materials and Capacitor Electrodes; and  
Capacitor Constructions

**VERSION WITH MARKINGS TO SHOW CHANGES MADE ACCOMPANYING  
RESPONSE TO APRIL 19, 2002 OFFICE ACTION**

**In the Claims**

The claims have been amended as follows. Underlines indicate insertions and  
~~strikeouts~~ indicate deletions.

Cancel claims 24-41.

**—END OF DOCUMENT—**

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